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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/566,838	02/02/2006	Daniele Pullini	463651	7477	
23117 NIXON & VA	7590 08/12/200 NDERHYE, PC	EXAMINER			
	LEBE ROAD, 11TH F	VALENTINE, JAMI M			
ARLINGTON,	VA 22203		ART UNIT	PAPER NUMBER	
			2894		
			MAIL DATE	DELIVERY MODE	
			08/12/2009	PAPER	

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

Advisory Action Before the Filing of an Appeal Brief

Application No.	Applicant(s)		
10/566,838	PULLINI ET AL.		
Examiner	Art Unit		
JAMI M. VALENTINE	2894		

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The MAILING DATE of this communication appe	ars on the cover sheet with the c	correspondence add	ess
THE REPLY FILED <u>03 August 2009</u> FAILS TO PLACE THIS AF	PPLICATION IN CONDITION FOR	ALLOWANCE.	
1. The reply was filed after a final rejection, but prior to or on application, applicant must timely file one of the following rapplication in condition for allowance; (2) a Notice of Apple for Continued Examination (RCE) in compliance with 37 C periods:	replies: (1) an amendment, affidaviral (with appeal fee) in compliance	t, or other evidence, w with 37 CFR 41.31; or	hich places the (3) a Request
a) \boxtimes The period for reply expires $\underline{4}$ months from the mailing date	of the final rejection.		
b) The period for reply expires on: (1) the mailing date of this Adno event, however, will the statutory period for reply expire la Examiner Note: If box 1 is checked, check either box (a) or (I MONTHS OF THE FINAL REJECTION. See MPEP 706.07(f	iter than SIX MONTHS from the mailing b). ONLY CHECK BOX (b) WHEN THE).	g date of the final rejectio FIRST REPLY WAS FIL	n. .ED WITHIN TWO
Extensions of time may be obtained under 37 CFR 1.136(a). The date of have been filed is the date for purposes of determining the period of extra under 37 CFR 1.17(a) is calculated from: (1) the expiration date of the size forth in (b) above, if checked. Any reply received by the Office later may reduce any earned patent term adjustment. See 37 CFR 1.704(b). NOTICE OF APPEAL	ension and the corresponding amount of the hortened statutory period for reply origing the contract of the con	of the fee. The appropria nally set in the final Offic	ite extension fee e action; or (2) as
 The Notice of Appeal was filed on A brief in compl filing the Notice of Appeal (37 CFR 41.37(a)), or any exten Notice of Appeal has been filed, any reply must be filed wind AMENDMENTS 	sion thereof (37 CFR 41.37(e)), to	avoid dismissal of the	
3. The proposed amendment(s) filed after a final rejection, b	out prior to the data of filing a brief	will not be entered be	031160
(a) ☐ They raise new issues that would require further con (b) ☐ They raise the issue of new matter (see NOTE below (c) ☐ They are not deemed to place the application in bett	isideration and/or search (see NOT w);	ΓE below);	
appeal; and/or			
(d) They present additional claims without canceling a converse NOTE: (See 37 CFR 1.116 and 41.33(a)).	forresponding number of finally reje	ected ciaims.	
4. The amendments are not in compliance with 37 CFR 1.12	21. See attached Notice of Non-Co	mpliant Amendment (F	PTOL-324).
5. Applicant's reply has overcome the following rejection(s):			,
 Newly proposed or amended claim(s) would be allowed non-allowable claim(s). 	·	-	
7. For purposes of appeal, the proposed amendment(s): a) how the new or amended claims would be rejected is prov. The status of the claim(s) is (or will be) as follows: Claim(s) allowed:		l be entered and an ex	planation of
Claim(s) objected to: Claim(s) rejected: <u>18-23</u> . Claim(s) withdrawn from consideration:			
AFFIDAVIT OR OTHER EVIDENCE			
 The affidavit or other evidence filed after a final action, but because applicant failed to provide a showing of good and was not earlier presented. See 37 CFR 1.116(e). 			
9. The affidavit or other evidence filed after the date of filing a entered because the affidavit or other evidence failed to or showing a good and sufficient reasons why it is necessary	vercome <u>all</u> rejections under appea	al and/or appellant fails	s to provide a
10. ☐ The affidavit or other evidence is entered. An explanation REQUEST FOR RECONSIDERATION/OTHER	n of the status of the claims after er	ntry is below or attache	∍d.
11. The request for reconsideration has been considered but See Continuation Sheet.	does NOT place the application in	condition for allowand	e because:
12. ☐ Note the attached Information <i>Disclosure Statement</i>(s). (13. ☐ Other:	PTO/SB/08) Paper No(s)		
/JMV/	/THANH V. PHAM/ Primary Examiner, Art U	nit 2894	

Continuation of 11. does NOT place the application in condition for allowance because: The amended and newly proposed claims would be rejected as in the Final Office action.

The following is a response to Applicants arguments: Applicants arguments (page 7) that the finality of the previous Office action should be withdrawn are not persuasive. MPEP 706.07(a) details when a final rejection can properly be made on a second action: "Furthermore, a second or any subsequent action on the merits in any application or patent undergoing reexamination proceedings will not be made final if it includes a rejection, on newly cited art, other than information submitted in an information disclosure statement filed under 37 CFR 1.97(c) with the fee set forth in 37 CFR 1.17(p), of any claim not amended by applicant or patent owner in spite of the fact that other claims may have been amended to require newly cited art." The final rejection mailed 4/1/09 did not include a rejection on newly cited art, the same prior art was applied. The rejection under 35 USC 112 second paragraph (see Final rejection paragraph 6-13) was necessitated by Applicants amendments to the claims filed 12/29/08. In the previously examined claims it was clear that the spacer element and spacer layer were the same part because of the numerical character references. Applicants 12/29/08 amendment removed those character references causing an antecedent basis issue for the use of spacer layer and spacer element. Applicants amendment also added a step of chemically etching the semiconductor substrate which was not previously examined and necessitated the 112 rejection.

Applicants arguments (page 8) regarding whether the drawings show the spin valve as claimed are not persuasive.

Applicants arguments regarding paragraph 9 (pages 8-9) clarify the fabrication of the spacer layer using a substrate with references to the figures and specification, however these details are not clear from the claim language, and it is noted that the features upon which applicant relies (i.e., the etched substrate can be laid onto any other substrate) are not recited in the rejected claim(s). Although the claims are interpreted in light of the specification, limitations from the specification are not read into the claims. See In re Van Geuns, 988 F.2d 1181, 26 USPQ2d 1057 (Fed. Cir. 1993).

Applicants arguments regarding paragraph 10 (page 9) are moot in view of the amendments to the specification.

Applicants arguments regarding paragraph 11 (page 9) are not persuasive. As claimed, the spacer layer is formed by etching and forming pores in a semiconductor substrate, then applying metallic nano particles to the substrate to form a disordered mesoscopic structure. This does not produce a dielectric. A dielectric is a non-conducting substance, i.e. an insulator. Applicants specification does support a dielectric spacer, but the claims explicitly use a semiconductor substrate and metallic nanoparticles.

Applicants arguments regarding the applied prior art, Fujiwara (pages 10-11) are not persuasive since Fujiwara's disclosure anticipates the claimed structure. In response to applicant's argument that the references fail to show certain features of applicant's invention, it is noted that the features upon which applicant relies (i.e., microstructure of the composite) are not recited in the rejected claim(s). Although the claims are interpreted in light of the specification, limitations from the specification are not read into the claims

Applicant argues that the methods mentioned by Fujiwara do not lead to the production of a material with properties similar to that of the claimed material. The examiner notes that the claims are directed to a product and contain product-by-process claims. While product-by-process claims are limited by and defined by the process, determination of patentability is based on the product itself. In re Hirao, 190 USPQ 15 at 17(footnote 3). The patentability of a product does not depend on its method of production.

Applicant states (page 11) that "it is presently claimed that a semiconductor or dielectric substrate (31) is subjected to a chemical etching process..." The examiner disagrees. The claims include a semiconductor substrate but do not include a dielectric substrate.

Applicant argues (pages 11-12) that Fujiwara does not mention any pore or porous structure. This argument is not persuasive since Fujiwara figures 2 and 3A-B clearly show pores. Fujiwara also discloses that the pores can be filled with nanowires [0019] which are conducting [0022], hence anticipating the claimed structure.

Applicant argues (page 12) that it isn't possible to ascertain the electrical or magnetic properties of the device of Fujiwara. This argument is not persuasive since the structure is anticipated.

Applicant argues (page 12) that nanowires grown in the pore of a porous templates are different from nanowires grown by other methods, i.e. codeposition, and provided a reference describing the way electrodeposition in the nanopores can be controlled for tailoring the crystal structure. However the claims do not require electrodeposition. Hence this argument is not persuasive.